

**Search Notes**

Application No.

10/035,137

Examiner

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Applicant(s)

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Art Unit

1752

**SEARCHED**

Class	Subclass	Date	Examiner
430	165	5/04	JSC
430	191	↓	↓
430	192		
430	193	↓	↓

**INTERFERENCE SEARCHED**

Class	Subclass	Date	Examiner
430	165	5/04	JSC
430	191,192	↓	↓
430	193	↓	↓

**SEARCH NOTES  
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
Reviewed copending application 10/084,204 and 09/322,978, U.S. patent 6,379,859	5/04	JSC